

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	24	ITATANI-HIDEHARU	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:22
L2	1	HORU-ET-AL	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:23
L3	0	HORU-ET-ALASAI-MASAYUKI	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:24
L4	95	ASAI-MASAYUKI	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:24
L5	62	HORII-SADAYOSHI	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:25
L6	200	SANO-ATSUSHI	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:25
L7	17	(1 or 4 or 5 or 6) and (ald or (atomic adj layer adj deposition))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:26
L8	14	7 and (cvd or pecvd)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:26

L9	7117	"14" and (thermal adj cvd)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:30
L10	5	8 and (thermal adj cvd)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:31
L11	4499	(ald or (atomic adj layer adj deposition)) same (cvd or (thermal adj1 deposit\$4)) same (metal or ru or ruthenium or "ruo.sub.2" or ti or titanium or tungsten or w or aluminum or al)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:36
L12	3543	(ald or (atomic adj layer adj deposition)) same (cvd or (thermal adj1 deposit\$4)) same (metal or ru or ruthenium)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:36
L13	30	12 and (radical\$1 and (nucleation adj layer))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:37
L14	526	((ald or (atomic adj layer adj deposition)) and (cvd or (thermal adj1 deposit\$4)) and (metal or ru or ruthenium)).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:39
L15	166	((ald or (atomic adj layer adj deposition)) same (cvd or (thermal adj1 deposit\$4)) same (metal or ru or ruthenium)).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:40

L16	16	((ald or (atomic adj layer adj deposition)) and (cvd or (thermal adj1 deposit\$4)) and (metal or ru or ruthenium) and radical\$1 and plasma).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:41
L17	256	((ald or (atomic adj layer adj deposition)) and (cvd or (thermal adj1 deposit\$4)) and (metal or ru or ruthenium) and plasma).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:41
L18	256	((ald or (atomic adj layer adj deposition)) and (cvd or (thermal adj1 deposit\$4)) and (metal or ru or ruthenium) and plasma).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/07/09 14:41

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